

Attorney Docket No. 071469-0307699
Client Reference: ES-040

PATENT



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re application of: HONGYU YUE

Application No.: 10/812,355

Confirmation 4102

No:

Filed: March 30, 2004

Group No.: 1742

Examiner

For: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE REMOVAL
PROCESS USING PARTIAL PRESSURE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76

BIBLIOGRAPHIC DATA

1. Applicant information

First applicant: HONGYU YUE
Citizenship: Peoples' Republic of CHINA
Residence: Austin, TX 78479

2. Correspondence information

Correspondence for this application should be addressed as follows:

Customer No.: 00909

3. Application information

Title of Invention: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE
REMOVAL PROCESS USING PARTIAL PRESSURE

Docket number assigned to this application: 071469-0307699

Suggested Classification: Class:

Subclass:

Technology Center to which subject matter is assigned:

Total number of drawing sheets: 22

Type of application: Utility

Application is to be published. Suggested drawing figure for publication:

Secrecy order under § 5.2:

This application does not disclose subject matter of an application which is under a secrecy order pursuant to § 5.2.

4. Representative information

The following have a power of attorney or authorization of agent in this application:

Customer No.: 00909

5. Assignee information

The assignee(s) of this application is/are:

Tokyo Electron Limited

3-6, Akasaka 5-chome, Minato-ku

Tokyo, 107

JAPAN

Extent of interest of assignee in application: 100%

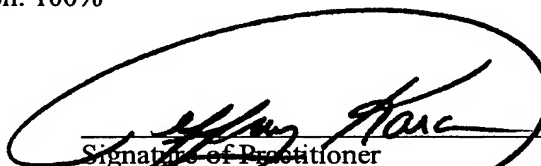
Date: June 24, 2004

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Signature of Practitioner
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